



IFCW

Docket No.: P2000,0361

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 10/609,464
Applicant : Wolfgang Dickenscheid, et al.
Filed : June 27, 2003
Art Unit : 2123
Title : Method for Characterizing and Simulating a Chemical Mechanical Polishing Process
Docket No. : P2000,0361
Customer No. : 24131

S T A T U S L E T T E R

Commissioner for Patents,
P.O. Box 1450, Alexandria, VA 22313-1450

Sir:

It is respectfully requested that this Status Letter be returned to:

LERNER AND GREENBERG, P.A.
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Tel: (954) 925-1100
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with an indication as to when an action may be expected.

Respectfully submitted,

Alexia J. Vrahimis

Date: January 14, 2005

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